

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application __		OFCS File No. P/1929-101		
		Applicant Akira MONDEN		10/591427		
		Filing Date __		Group Art Unit __		
<b>U.S. PATENT DOCUMENTS</b> (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
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<b>FOREIGN PATENT DOCUMENTS</b>						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes      No
	JP 09-167230	06-1997	Japan			Abstract
	JP 2002-288641	10-2002	Japan			Abstract
	JP 2002-288672	10-2002	Japan			Abstract
	WO 01/55966 A1	08-2001	Japan			Abstract
	JP 2002-099912	04-2002	Japan			Abstract
	JP 2003-044856	02-2003	Japan			Abstract
	JP 08-110949	04-1996	Japan			Abstract
	JP 08-129644	05-1996	Japan			Abstract
	JP 08-110945	04-1996	Japan			Abstract
	JP 63-308679	12-1988	Japan			Abstract
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Nobuyuki, O., "An Automatic Threshold Selection Method Based on Discriminant and Least Squares Criteria", The Institute of Electronics, Information and Communication Engineers Transactions, Vol. J63-D, No. 4, pp. 359-356				
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